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PATENT
81754.0075

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Toshihiko HIGUCHI

Serial No: 09/754,818

Filed: January 4, 2001

For: SEMICONDUCTOR DEVICE HAVING A
WIRING PATTERN AND METHOD FOR
MANUFACTURING THE SAME

Art Unit: 2814

Examiner: Phat X. Cao

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on
October 20, 2003

Date of Deposit
Anthony J. Orler Reg. No. 41,232
Name
Signature
Date 10/20/03

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FC 2814

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a one-month extension of time extending to October 20, 2003, the period for response to the Office Action dated June 20, 2003. Please charge the fee of \$110 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,
HOGAN & HARTSON L.L.P.

Date: October 20, 2003

By:
Anthony J. Orler
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